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# **Micro and Nano-Manufacturing**

Guest Editor:

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Deadline for manuscript submissions: closed (30 November 2018)

### Message from the Guest Editor

Dear Colleagues,

Micro- and nano-scale manufacturing is gaining more attention due to production miniaturization and customization. High precision and product quality are difficult to achieve at this length scale; thus, a deeper understanding of the processes, development of characterization methods, modeling and simulations, and monitoring are required for the improvement of product quality and mass scale productivity. This Special Issue of JMMP will focus on advances in micro- and nano-scale manufacturing processes and systems that address the aforementioned requirements. Both theoretical and experimental contributions are welcome. Applicationoriented novel manufacturing processes and systems are also of interest

Dr. Martin Byung-Guk Jun Guest Editor









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### Message from the Editor-in-Chief

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